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09/829587
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Subclass	Class	ISSUE CLASSIFICATION
04	09	01

PATENT NUMBER

U.S. UTILITY Patent Application

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PATENT DATE

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/829587		438 156	7.0	1765 1763	Aco 76225 <i>Zachary</i>

APPLICANTS

Pavel Laptev

345,44

TITLE

System for, and method of, etching a surface on a wafer

PTO-2040
12/89

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